

Serial No. 10/675,987
Amdt. dated December 8, 2005
Reply to Office Action of August 8, 2005

Docket No. YHK-0121

Amendments to the Abstract:

Please replace the Abstract filed with the original application with the substitute Abstract filed herewith. No new matter is added.

Serial No. 10/675,987

Docket No. YHK-0121

Amdt. dated December 8, 2005

Reply to Office Action of August 8, 2005

ABSTRACT

An improved protective film for a plasma display panel and a fabricating method thereof are provided. The improved protective film has magnesium oxide (MgO) as its main component, and uses a slight addition of silicon (Si) to improve jitter characteristics experienced during the address period.